

Stable and Catalytically Active Shape-Engineered Cerium Oxide Nanorods by Controlled Doping of Aluminum

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ABSTRACT

Shape-engineered nanocrystals (SENs) promise a better selectivity and a higher activity in catalytic reactions than the corresponding non-shape-engineered ones owing to their larger specific surface areas and desirable crystal facets. However, often, these SENs are less stable because the desirable surface facets have higher specific surface energies than other types of facets. Therefore, it is challenging to apply SENs in practical catalytic applications at high reaction temperatures to achieve favorable kinetics. In this paper, we show that atomic layer deposition of Al_2O_3 can modify the shape-engineered CeO_2 nanorods (NRs) to not only increase their shape transition temperature from 400 °C to at least 700 °C, but also greatly increase their specific reversible oxygen storage capacity (srOSC) up to 700 °C. Through Al_2O_3 atomic layer deposition at 200 °C, trimethyl aluminum reduces the Ce^{4+} to Ce^{3+} and substitutes Ce^{3+} ions with Al^{3+} to form -Al-O-Ce-O- structure. The substituted Al^{3+} ions impede the surface diffusion of Ce ions, therefore improve the thermal stability of CeO_2 NRs. The Ce ion in -Al-O-Ce-O-, a new Ce species, can be reversibly reduced and oxidized at 500 – 700 °C. Our method presents a new strategy to improve the thermal stability and catalytic activities of SENs, thereby expand their applications into high temperature environments.

KEYWORDS: shape-engineered, ceria, aluminum oxide, atomic layer deposition, stability

INTRODUCTION

Cerium oxide (CeO_2) plays important roles as catalysts and/or catalyst supports in a wide range of applications, including three-way catalysts on catalytic converters of cars,¹ catalysts for fluidized-bed catalytic cracking,² catalytic oxidation of soot from diesel engines,³ and solid oxide fuel cells,⁴⁻⁵ to name a few. All of these applications utilize CeO_2 because it has an exceptionally large specific (per unit mass of CeO_2) reversible oxygen storage capacity (srOSC), which originates from the redox reactions: $2\text{Ce}_2\text{O}_3 + \text{O}_2 \rightleftharpoons 4\text{CeO}_2$.¹ These practical applications demand not only a large srOSC but also a facile redox kinetics, *i.e.*, a large amount of srOSC that can be extracted at a lower temperature at a faster rate.^{4, 6-15} The redox kinetics of pure CeO_2 depends strongly on its size, shape, and crystal facets.^{12, 16-19} In comparison with other types of CeO_2 nanomaterials, shape-engineered CeO_2 nanorods (NRs) has more facile redox kinetics for srOSC,^{12, 16, 18-19} owing to their unique physiochemical properties, including **(i)** the high density of {100} and {110} facets, which are more reducible than {111} facets;^{12, 19-21} **(ii)** the high density of defects.^{1, 12, 15, 22-24} However, these shape-engineered CeO_2 NRs permanently lose their facile redox kinetics if heated above 400 °C, because they deform into thermally more stable octahedrons, which have {111} as the dominating surface facets, and aggregate.^{15, 23, 25-27} This inferior thermal stability severely limits their applications in high temperature environments in order to achieve fast reaction kinetics.

The poor thermal stability of highly active SENs, including CeO_2 NRs, is due to the diffusion of surface and bulk atoms.²⁸⁻³⁰ In order to diffuse, atoms need to break and reform bonds with surround atoms.³¹ Diffusion of a surface atom is activated at lower temperatures than diffusion of a bulk atom because surface atoms have fewer bonds with the surrounding atoms than atoms in bulk. Therefore, it is possible to improve the thermal stability of SENs by suppressing the diffusion of surface atoms by surface modification.

In this paper, we present a new strategy that not only maintains the facile low temperature redox kinetics of srOSC of shape-engineered CeO_2 NRs, but also improves their thermal stability to at least 700 °C so that a large amount of sub-surface and bulk oxygen can be extracted as well. Our method is to controllably modify these shape-engineered CeO_2 NRs with atomic layer deposition (ALD). Because the unique delayed nucleation of ALD Al_2O_3 on dehydrated CeO_2 NRs, Al dopes onto CeO_2 NRs and substituted some Ce ions on the surface of NRs on a large scale, while not fully cover the surface of NRs to deactivate their useful srOSC. The controlled Al dopants reduces the diffusion of surface atoms on CeO_2 by increasing the strength and number of chemical coordination of surface ions and by increasing the tortuosity and/or blocking the diffusion pathways of Ce ions of CeO_2 .

RESULTS

Improved shape stability of shape-engineered CeO₂ NRs upto 700 °C.

Figure 1 shows the low magnification TEM images of CeO₂ NRs followed by various treatments. Figure 1a shows a typical TEM image of shape-engineered CeO₂ NRs sample, which consists mainly of rods and the amount of other shapes is negligible. There is variation in the aspect ratios of CeO₂ NRs. These shape-engineered CeO₂ NRs were synthesized at temperatures lower than 100 °C (details in the experimental section). As presented in Figure 1b, these CeO₂ NRs lose their rod shapes and transform into spherical or irregular-shaped nanoparticles after annealing at 700 °C in air for 5h (this treatment is named as HT: high temperature treatment), suggesting that these CeO₂ NRs are thermally unstable. The morphology change is consistent with literature observation of the CeO₂ NRs that are synthesized through the same method.²⁶⁻²⁷ Figure 1c and 1d show that 45 cycles of Al₂O₃ ALD do not alter the rod morphology of CeO₂ NRs. Therefore, the ALD reaction temperature (200 °C) and the ALD chemistry do not affect the morphology of the sample. For convenience, we name CeO₂ NRs after n cycles of Al₂O₃ ALD treatment as CeO₂NR/nAl₂O₃. Figure 1e and 1f show that CeO₂NR/45Al₂O₃ preserved its rod shape after annealed at 700 °C in air for 5h. We name this sample as CeO₂NRs/45Al₂O₃_HT. In comparison with the results in Figure 1b, the results in Figure 1e-1f indicate that 45-cycle ALD Al₂O₃ treatment dramatically improves the thermal stability of the CeO₂ NRs. Figure 1g-1h present the morphology of the samples of CeO₂NR/1Al₂O₃_HT and CeO₂NR/10Al₂O₃_HT, which are named according to the same method as CeO₂NR/45Al₂O₃_HT. CeO₂NR/1Al₂O₃_HT has numerous spherical nanoparticles, while CeO₂NR/10Al₂O₃_HT has negligible spherical nanoparticles. Therefore, we conclude that ALD Al₂O₃ treatment can improve the morphology stability of shape-engineered CeO₂ NRs and the degree of stability enhancement depends on the number of ALD cycles.

High resolution scanning transmission electron microscopy (STEM) images were taken to understand the effect of Al_2O_3 ALD treatment on the detailed microstructure of CeO_2 NRs. Figure 2a and 2b show that CeO_2 NRs grow along the $\{110\}$ direction with side surfaces of $\{100\}$ and $\{110\}$. In addition, these CeO_2 NRs are well crystallized before ALD process. The figures show that these shape-engineered CeO_2 NRs have surface defects, which could contribute to the facile oxygen redox kinetics. As shown by Figure 2c and 2d, $\text{CeO}_2\text{NR}/45\text{Al}_2\text{O}_3$ still maintain $\{110\}$ as the main axial and $\{100\}$ and $\{110\}$ as the surface facets along the sides of the CeO_2 NRs. We do not observe an amorphous Al_2O_3 shell around the CeO_2 NRs. This result is a surprise because 45 ALD cycles could produce amorphous Al_2O_3 shell of $\sim 4\text{-}5$ nm if Al_2O_3 ALD nucleation follows the typical steady state growth rate of Al_2O_3 ALD, which is around $1 \text{ \AA}/\text{cycle}$ at 200°C . Therefore, the nucleation of Al_2O_3 ALD is significantly delayed and we will discuss it in details in later sections.

The microstructures of $\text{CeO}_2\text{NR}/45\text{Al}_2\text{O}_3\text{_{HT}}$ and $\text{CeO}_2\text{NR_HT}$ were also analyzed by STEM to illustrate the effect of HT on the microscopic crystal structures of CeO_2 NRs. Figure S1a – S1c show some typical images from these analyses. According to the figures, the shape of nanorods is largely maintained for $\text{CeO}_2\text{NR}/45\text{Al}_2\text{O}_3\text{_{HT}}$ sample. These nanorods have an average diameter less than 10 nm. Surfaces of these NRs become sharper than the $\text{CeO}_2\text{NR}/45\text{Al}_2\text{O}_3$. In contrast, $\text{CeO}_2\text{NR_HT}$ sample mainly consists of large particles, as shown by Figure S1d. These large particles are generated from the deformation and aggregation of CeO_2 NRs owing to the thermal diffusion of Ce.³²⁻³³ The main surface facet of these large nanoparticles is $\{111\}$, which is thermodynamically more stable than $\{110\}$ and $\{100\}$ facets but does not have low temperature oxygen storage capability.^{12, 16-19} This shape transformation is consistent with the result in Figure 1b. Figure S1 confirms that the high temperature annealing does not affect the nanorod morphology of $\text{CeO}_2\text{NR}/45\text{Al}_2\text{O}_3$, while the same high temperature annealing transforms CeO_2 NRs into large CeO_2 nanoparticles with $\{111\}$ surface facet.

The distribution of diameters of the shape-engineered CeO₂ NRs, CeO₂NR_HT, CeO₂NR/45Al₂O₃, and CeO₂NR/45Al₂O₃_HT were measured and summarized in Figure 3. CeO₂NR/45Al₂O₃ and CeO₂NR/45Al₂O₃_HT have a similar average diameter as CeO₂ NRs. CeO₂NR_HT has a much larger diameter than the CeO₂ NRs and CeO₂NR/45Al₂O₃_HT. This result further confirmed that the ALD Al₂O₃ treatment can stabilize the morphology of CeO₂ NRs at high temperatures, i.e., 700 °C in this study.

Improved reversible oxygen storage capacity of shape-engineered CeO₂ NRs

ALD Al₂O₃ can stabilize the shape of CeO₂ NRs, it is more important and interesting to find out how the ALD Al₂O₃ treatment affects the specific reversible oxygen storage capacity of the CeO₂ NRs. Figure 4 presents the H₂ consumption result (measured by hydrogen temperature programmed reduction, H₂-TPR, details in experimental section) as a function of temperature for the pure CeO₂ NRs and the CeO₂ NRs after various treatments. The integrated area below the curve represents the amount of H₂ consumption, *i. e.*, the amount of oxygen that can be extracted by H₂. As illustrated by the curve of 1st H₂-TPR cycle of CeO₂ NRs (Figure 4a), the reduction of fresh CeO₂ NRs by H₂ takes off around 260 °C, peaks at 480 °C, and ends at ~ 580 °C. The second reduction peak takes off at 580 °C and ascends to 700 °C, which is the unbound temperature for the TPR experiment. The low temperature reduction peaked at 480 °C is ascribed to the consumption of H₂ by surface oxygen on CeO₂ NRs. The reduction at higher temperature (>580 °C) is due to the H₂ that reacts with the bulk oxygen inside of CeO₂ NRs. This H₂ consumption behavior matches well with literature results of the fresh CeO₂ NRs that are prepared in the similar way.^{12, 18, 34} After cooling the sample down and leaving in air for a day at room temperature, we ran the 2nd cycle of H₂-TPR for the sample, whose reduction behavior differs dramatically from that in the 1st H₂-TPR cycle. Although the H₂ consumption still takes off at 260 °C, the height of the 1st peak, which now shifts to 420 °C, decreased dramatically. The 2nd reduction peak also decreased a lot. This reduction behavior is similar as that of CeO₂NR_HT

(Figure 4a), except that CeO₂NR_HT sample has a higher initial reduction temperature and much less H₂ consumption, *i.e.*, the specific quantity of reducible oxygen, because HT treatment deforms the shape-engineered CeO₂ NRs into spherical or irregular-shaped nanoparticles. According to these results, annealing fresh CeO₂ NR at 700 °C in N₂ or H₂ will irreversibly damage the oxygen species that can be reduced at low temperatures. Figure 4a also illustrates how the number of ALD Al₂O₃ cycles affects the srOSC of CeO₂ NRs by comparing the TPR curves from CeO₂NRs/1Al₂O₃_HT, CeO₂NRs/10Al₂O₃_HT, and CeO₂NRs/45Al₂O₃_HT. CeO₂NRs/1Al₂O₃_HT shows a small H₂ consumption peak at ~480 °C. CeO₂NRs/10Al₂O₃_HT has two H₂ consumption peaks at 420 °C and 550 °C and has a much larger amount of reducible oxygen than CeO₂NRs/1Al₂O₃_HT. In a similar fashion as CeO₂NRs/45Al₂O₃_HT, the peak of CeO₂NRs/10Al₂O₃_HT at 550 °C is from a large amount of new types of oxygen species that can be reduced between 500 – 700 °C. The CeO₂NRs/10Al₂O₃_HT has a smaller srOSC than CeO₂NRs/45Al₂O₃_HT in the temperature upto 700 °C. In summary, Figure 4a show that ALD Al₂O₃ treatment increases the specific reversible OSC in CeO₂ NRs upto 700°C and the degree of improvement increases with number of ALD cycles.

CeO₂NRs/45Al₂O₃_HT shows a dramatically different TPR behavior than CeO₂ NRs. *First*, the most significant feature is that CeO₂NRs/45Al₂O₃_HT maintained a stable H₂-TPR profile, *i.e.*, stable srOSC, as evidenced by the 1st-10th TPR cycles of the sample (Figure 4b). TPR up to 700 °C did not damage its srOSC. The exposure to air at room temperature can quickly replenish oxygen back into the H₂-reduced CeO₂NRs/45Al₂O₃_HT. The 1st TPR cycle has a higher H₂ consumption peak at the low temperature reduction (~480 °C) than that in 2-10 cycles of TPR is higher than that from the 1st cycle and the peak at 550 °C improves as well, meaning that the 1st TPR cycle changed the material to a more stable form. *Second*, although CeO₂NRs/45Al₂O₃_HT has a smaller peak at ~450 °C than that the 1st TPR cycle of the fresh CeO₂ NR, it consumes a much higher amount of H₂ at the temperature range of 450 - 600 °C, according to the area

underneath the curve. This result suggests CeO₂NRs/45Al₂O₃_HT has a much larger srOSC than fresh CeO₂ NRs at temperature below 700 °C. *Third*, CeO₂NRs/45Al₂O₃_HT has a much larger srOSC than CeO₂NR_HT. According to these results, we conclude that CeO₂NR/45Al₂O₃_HT has a much larger srOSC than pristine CeO₂ NRs upto 700 °C and has oxygen species that can be reduced by H₂ between 500 °C and 600 °C, which is beneficial for applications demanding intermediate temperature below 700 °C, such as intermediate-temperature fuel cells.

Chemical composition of CeO₂ NRs with ALD Al₂O₃ treatment and/or HT treatment

As TEM analyses of CeO₂NRs/45Al₂O₃ cannot clearly differentiate Al₂O₃ coating from CeO₂ NRs, we analyzed the nanoscale chemical composition of nanorods by HAADF-EDX mapping for samples of CeO₂NRs/45Al₂O₃ and CeO₂NRs/45Al₂O₃_HT. Figure 5a and 5e show the morphology of CeO₂NRs/45Al₂O₃ and CeO₂NRs/45Al₂O₃_HT respectively, confirming that CeO₂ NRs maintained the rod structure after high temperature treatment. The EDX mapping show that O and Ce are homogeneously distributed throughout the bulk of the CeO₂ NRs in CeO₂NRs/45Al₂O₃ (Figure 5c and 5d) and CeO₂NRs/45Al₂O₃_HT (Figure 5g and 5h). In contrast, Al is located at the external surface of the CeO₂ NRs (Figure 5b and 5f). Al does exist on the top ~ 1 nm region which is much thinner than a 4 – 5 nm shell what would be expected for 45 cycles ALD Al₂O₃ on the metal-OH surface.³⁵⁻³⁶ In addition, the presence of Al is not continuous and conformal. These results suggest a different reaction mechanism than that in the common Al₂O₃ ALD. Based on the comparison between Figure 5b and 5f, HT treatment did not drive significant diffusion of Al into the bulk of CeO₂ NRs. It makes sense as Al-O bonds are stable at 700 °C. According to the overall EDX mapping of the CeO₂NRs/45Al₂O₃, Al distributes on all nanorods (Figure S2).

As ALD Al₂O₃ growth on CeO₂NRs at 200 °C does not follow the common nucleation and growth scheme on -OH surface, a different reaction mechanism happens. It was reported that –OH species on CeO₂ can be almost completely removed at 200 °C, which is same as our ALD

treatment temperature.³⁷⁻³⁸ Therefore, we hypothesize that –OHs on these CeO₂ NRs were removed before the ALD Al₂O₃ treatment. To test our hypothesis, the same ALD sequence was applied onto the CeO₂ NRs at two different temperatures: 75 °C and 200 °C using the flat boat method (see in the experiment section). Figure 6 shows the TEM results of the CeO₂NRs/45Al₂O₃ and CeO₂NRs/45Al₂O₃(75C). At 200 °C, no visible Al₂O₃ shell was formed on the CeO₂NRs after 45 cycles of Al₂O₃ ALD (Figure 6a). At 75 °C, in contrast, an Al₂O₃ shell of ~4.5 nm thickness was formed over the CeO₂ NRs (Figure 6b). This result aligns with hypothesis. At 75 °C, the surface of CeO₂ NR is populated with –OHs, which promote the nucleation and growth the Al₂O₃ shell through the common binary Al₂O₃ ALD chemistry. At 200 °C, however, because –OH groups on CeO₂ surface were removed, TMA directly reacts with CeO₂ through a reaction mechanism that is different and slower than that of binary Al₂O₃ ALD chemistry. We will discuss it further in the discussion section.

Figure 7a and 7b show the deconvoluted Ce 3d XPS spectrum of CeO₂NRs and CeO₂NRs/45Al₂O₃, respectively. Ce 3d shows split peaks resulting from the different valence states of Ce, including Ce³⁺ and Ce⁴⁺.³⁹⁻⁴⁴ The Ce⁴⁺ 3d_{3/2} and Ce⁴⁺ 3d_{5/2} peaks are located at 916.9 eV and 899.1 eV ± 0.2 eV, respectively. The Ce³⁺ 3d_{3/2} and Ce³⁺ 3d_{5/2} peaks are located at 901.7 eV and 886.7 eV ± 0.2 eV, respectively.³⁹⁻⁴⁴ Other small satellite peaks are due to the energy-gain processes, so-called shake-down peaks.^{40, 45} The atomic concentration of Ce³⁺ increases from 0.266 (CeO₂NRs) to 0.298 (CeO₂NRs/45Al₂O₃) based on the quantification of the Ce 3d XPS peaks for the corresponding samples. The higher concentration of Ce³⁺ indicates that ALD Al₂O₃ treatment reduced CeO₂ NRs to generate O vacancies and/or mobile oxygen species on the CeO₂ NRs surface. It is likely that Al³⁺ substitutes Ce ions during the ALD treatment. In addition, according to the inset photos of these two samples, CeO₂NRs/45Al₂O₃ is darker than CeO₂NRs. The darker color is a sign of partial reduction of CeO₂.⁴⁶⁻⁴⁷

XRD spectra of CeO₂NRs and CeO₂NRs/45Al₂O₃ are presented in Figure 8. Both samples have the characteristic XRD peaks of CeO₂, including {111}, {200}, {220}, and {311}. These peaks

in CeO₂NRs/45Al₂O₃ shift to higher values of 2θ based on the comparison between two spectra. The calculated lattice constant of the non-treated CeO₂ NRs is 5.415 Å ± 0.0026 Å, which decreased to 5.408 Å ± 0.0019 Å after the ALD Al₂O₃ treatment. This suggests that Al ions substituted Ce ions to form Ce-Al-O_x lattices. The shift of 2θ aligns with metal ion substituted CeO₂.⁴⁸⁻⁴⁹

All of the ALD treatment for the samples used for the H₂-TPR activity test above were synthesized using the tubing method (details in the experiment section). We then tried the same treatment on the CeO₂ NRs synthesized using the flatboat method (details in the experiment section), and the TPR results of the flatboat method treated samples were very different with the tubing method treated samples, as shown in Figure 9. The difference between the tubing and the flatboat methods were mainly the CeO₂ NRs sample bed thickness. The powder bed thickness in the tubing method was ~3 mm and in the flatboat method was ~0.3 mm. The ratio of the sample bed thickness between the tubing method and the flatboat method was only around 10:1. The TPR results shows that when using the same ALD Al₂O₃ treatment sequence, the flatboat method treated CeO₂ NRs lost most of its surface srOSC before HT. The srOSC of the CeO₂NRs/45Al₂O₃_HT made by the flatboat method increased a little bit, which should be due to the change on the nanorod surface during the HT. Comparing to the CeO₂NRs/45Al₂O₃_HT made by the tubing method, the srOSC of the sample made by the flatboat method was much smaller. Therefore, the sample bed thickness must have affected the reaction. Based on the gas diffusion theory, it takes much longer time for TMA to diffuse through the thicker sample bed in the tubing method than the thinner sample bed in the flatboat method. Therefore, CeO₂ NRs have much less reaction time with TMA overall in the tubing method than in the flatboat method. According to the report of J. W. Elam, et, al,⁵⁰ the time for TMA to diffuse through the sample bed is proportional to the square of the sample bed thickness, so the time needed for TMA to diffuse through the sample bed is 100 times more in the tubing method. Because of this, the overall reaction time between the TMA, water and the CeO₂ NRs needed to be shorten when using flatboat method,

in order to have the similar average reaction time as the tubing method. To prove this hypothesis, another experiment was tried with only 1/10 of the TMA and water exposure time in each ALD cycle by using the flatboat method. The TPR result of the $\text{CeO}_2\text{NRs}/45\text{Al}_2\text{O}_3\text{_{HT}}$ made by the flatboat method shows very similar result as the $\text{CeO}_2\text{NRs}/45\text{Al}_2\text{O}_3\text{_{HT}}$ made by the tubing method, with a little bit lower surface reduction peak at $\sim 480^\circ\text{C}$ and even better light-off temperature. This results indicate that the ALD Al_2O_3 on the CeO_2 NRs is a rate controlled reaction. Long reaction time can eliminate the srOSC of the CeO_2 NRs but short reaction time can enhance both the srOSC and the thermal stability of the CeO_2 NRs.

DISCUSSION

Based on the TEM (Figure 1) and TPR measurements (Figure 5), ALD Al_2O_3 treatment not only stabilizes the morphology of the CeO_2 NRs, but also increases their srOSC (up to 700 °C). This new type of $\text{CeO}_2\text{NRs}/\text{Al}_2\text{O}_3$ can be applied in applications that operate at the temperatures higher than 700 °C and require a high srOSC below 500 °C. In this section, we present our hypothetic mechanisms for the improved thermal stability of morphology and srOSC properties of $\text{CeO}_2\text{NRs}/45\text{Al}_2\text{O}_3$ and the formation mechanism of $\text{CeO}_2\text{NRs}/45\text{Al}_2\text{O}_3$.

Why does $\text{CeO}_2\text{NRs}/45\text{Al}_2\text{O}_3$ maintain the nanorod morphology up to 700 °C?

To answer this question, let's first exam why CeO_2 NRs deform into CeO_2 nanoparticles when they are annealed at temperatures higher than 400 °C (Figure 1). Note, similar deformation is observed by other researchers as well.^{15, 23, 25-27} This deformation is driven by the minimization of the molar Gibbs energy of the material at the same temperature and pressure (1 atmospheric pressure). *First*, the deformation reduces the specific surface area, thereby the specific (per kg of CeO_2) surface Gibbs energy of the materials, because the resulting CeO_2 nanoparticles have a smaller specific surface area than the CeO_2 NRs. *Second*, the resulting CeO_2 nanoparticles have a lower surface energy per cm^2 than that of the original CeO_2 NRs because CeO_2 NRs is dominated with surface facets of {110} and {100}, which have higher surface energy than the dominating surface facets of {111} on CeO_2 nanoparticles.^{12, 19-21} Therefore, thermodynamically, annealing reduces the specific surface area and surface energy per cm^2 of CeO_2 nanocrystals.

Kinetically, CeO_2 NRs deform into nanoparticles because Ce ion moves around faster at higher temperatures. At 400 °C or above, Ce ions on {110} and {100} surfaces acquire enough energy to break surface bonds and move around. Ce ions in the bulk of CeO_2 may move as well, but at a much slower rate, because atoms in bulk CeO_2 crystals form more bonds with surrounding atoms, and it takes a higher energy to break more bonds in order to move around. The migration of Ce ions is accelerated by increasing the temperature, therefore CeO_2 NRs deforms much faster at 700 °C than at 400 °C. Note, the migration of O ions does not cause the deformation of CeO_2

NRs. For example, during the reduction and oxidation of CeO₂ NRs, O ions diffuse easily in and out of CeO₂ without deforming the crystal lattice. The reversible oxygen diffusion plays a key role to produce the reversible oxygen storage capacity of CeO₂.^{1, 51} Therefore, deformation of CeO₂ NRs is driven by the movement of Ce ions to reduce the material's Gibbs energy.

The thermally stable CeO₂NRs/45Al₂O₃ rods suggests that the migration of Ce ions is dramatically reduced in these samples in comparison with the pristine CeO₂ NRs. We hypothesize that the decorated Al₂O₃ nanoparticles play two roles in improving the shape stability of CeO₂ NRs. *First*, the decorated Al₂O₃ nanoparticles physically block and/or slow down the surface diffusion of Ce ions. It is known that the surface diffusion rates of atoms can be dramatically reduced by a step of one atomic height. *Second*, Al³⁺ will slow down the diffusion of Ce ions by substitute the Ce ions. Because Al-O bonding is strong and hard to break (evidenced by the absence of oxygen storage capacity of Al₂O₃), so the Al³⁺ ions block the Ce ions from moving around, therefore, the treated CeO₂ NRs became much more thermally stable.

Why does CeO₂NRs/45Al₂O₃ has a larger srOSC than CeO₂ NRs?

The following three mechanisms contribute to the improved srOSC of CeO₂NRs/45Al₂O₃ upto 700°C. *First*, majority of reducible surface oxygen from Ce-O bonding are still available because Al₂O₃ ALD does not form a conformal coverage around CeO₂ due to the sluggish nucleation and growth kinetics of Al₂O₃ ALD on CeO₂ at 200 °C. This non-conformal coverage of Al₂O₃ is clearly evidenced by the HAADF-EDX analyses (Figure 5). The non-conformal coverage is also shown by the activated CeO₂NRs/45Al₂O₃ made by the flat boat method using the same ALD sequence as the tubing method (Figure 9). *Second*, new types of reducible Ce species emerge as shown by the new reduction signal range from 500 to 600 °C. Based on the experimental data and the literature reports, we hypothesized the higher srOSC is from the formation of reducible Al-O-Ce-O- species on the surface and the sub-surfaces of CeO₂ NRs.

Although oxygen in O-Al cannot move to create oxygen vacancy, oxygen that bonds to Ce in -Al-O-Ce-**O**- but is not shared with Al could be activated at a lower temperature than the

corresponding oxygen in bulk CeO₂ lattice. Such -Al-O-Ce-O- species can be formed by substituting Ce⁴⁺ (radius of 1.01 Å) with the smaller Al³⁺ ions (radius of 0.53 Å). In -Al-O-Ce-O-, the Al ion will bond to and draw the oxygen ions closer to Al. XRD spectra of CeO₂ NRs and 45Al₂O₃/CeO₂NRs show that the lattice constant of CeO₂NRs/45Al₂O₃ is smaller than that of CeO₂ NRs. This fact is consistent with the formation of Al-O-Ce-O- structure,⁴⁸⁻⁴⁹ because the lattice constant of CeO₂ is measured to be 5.415 Å, and the simulated lattice constant of Al-O-Ce-O- is ~3.772 Å.⁵² In addition, DFT calculations from several reports show that the metal ion doped CeO₂ has longer Ce-O bond, which is weaker than the original bond.⁴³ The formation of Al-O-Ce-O- is consistent with findings in literature reports. For instance, literature reports that thermal stability of CeO₂ can be enhanced by doping with metal ions (M), such as La³⁺, Zr⁴⁺, Ti⁴⁺, Sn⁴⁺ etc,^{8, 49, 53-54} These small cation ions can substitute Ce⁴⁺ to form M-O-Ce-O- structure and the metal ion modified CeO₂ nanoparticles have better thermal stability and higher oxygen storage capacity.^{8, 48-49, 53} Therefore, new Al-O-Ce-O_x species are formed in CeO₂NRs/45Al₂O₃ and can create more reducible oxygen species at 500 – 600 °C to generate higher srOSC.^{48, 55-59} It is also interesting to note that these Al-O-Ce-O- sit in diversified environments, because oxygen reduction peak is wide, indicating the oxygen ions sit in different environments or different configurations.

How does ALD grow on CeO₂ NRs?

According to the TEM analysis, CeO₂NRs/45Al₂O₃ does not have a conformal 4-5 nm Al₂O₃-shell, which is expected for steady state 45 cycles of Al₂O₃ ALD on oxide surface covered by -OHs (Figure 6). The simplified reaction mechanism of TMA with -OH surface is shown in Eq. 1, where g represents gas, * represents the surface.



Our experiment results proved that Al₂O₃ ALD nucleates differently on -OH free CeO₂ NRs than on -OH dominated CeO₂ NRs at the growth temperature of 200 °C. Literature reported that almost all of the OH species are removed from CeO₂ at 200 °C.³⁷⁻³⁸ Therefore, TMA directly reacts with Ce-O-Ce bond on the CeO₂ surface that is free of OH. TMA will compete with Ce for

oxygen because TMA is one of the strongest Lewis acids, meaning the Al atom can bond with a lone pair of electrons on O. This reaction will reduce Ce^{4+} to Ce^{3+} and create oxygen vacancies; Meanwhile, Al^{3+} cations from ALD Al_2O_3 will be incorporated into the lattice of CeO_2 NRs to form Al-O-Ce-O-on the surface, or even the subsurface of the NRs. XRD (Figure 8) confirms this incorporation of Al. The XPS analysis (Figure 7) shows that concentration of Ce^{3+} increases after the ALD Al_2O_3 treatment. $-\text{CH}_3$ ligands on TMA could be oxidized into carbonyl groups or CO_2 . The reaction between TMA and CeO_2 produces a relatively inert surface so that the following cycles of ALD Al_2O_3 growth nucleates slowly.

There are methods to substitute Ce ions with other metal ions (M) to generate M-O-Ce-O-structure.^{8, 43, 47-48} In these methods, precursors are mixed in solution and calcined at high temperatures. These methods generally produce doped CeO_2 samples of spherical particles with octahedral crystal structures. These doped CeO_2 particles do not have reducible oxygen at low temperatures, e. g, at 400 °C. Also high temperature annealing is required to activate these dopants in CeO_2 particles for reversible oxygen storage. It is not possible to use these previous methods to synthesize CeO_2 NRs and dope it with other metal ions due to its poor thermal stability and controlled synthesize conditions. Our method, here, presents a viable low temperature method to controllably doped CeO_2 NRs while enhances their low temperature rsOSC.

Also, based on the results from comparative experiments of the tubing method and the flatboat method, the ALD reaction with CeO_2 NRs has slow reaction rate. According to the TPR results in figure 9, long precursor exposure time in flatboat method can deactivate the CeO_2 NRs, but short exposure time can maintain or even enhance the OSC of CeO_2 NRs. This means TMA can slowly react with CeO_2 and turning the surface into CeAlO_3 . If the reaction time is long enough, the whole surface will be turned into CeAlO_3 which completely blocked the O diffusion on the surface, so the TPR shows very small surface reduction peak at around 300-600°C in Figure 9. If the reaction time is short, the surface is partially turned into the CeAlO_3 , which create more reducible oxygen species on the surface and sub-surfaces which increased the srOSC of the NRs, so the TPR

shows very similar peaks as sample made by the tubing method (Figure 9). It is noticeable that the surface reduction peak around 450-500 °C of the 1/10 precursors exposure time using flatboat method is smaller than the surface peak of CeO₂NRs/45Al₂O₃ using tubing method. The reason could be that even 1/10 of the precursors exposure time is too long, so there are too much CeAlO₃ generated on the CeO₂ NR surface, which decreased the amount of the reducible oxygen species on the surface.

CONCLUSIONS

We presented a viable and controllable Al doping method, *i. e.*, ALD Al₂O₃ at 200 °C, to improve the thermal stability of CeO₂ NRs as well as their srOSC. This method is novel as it not only sustains the morphology of CeO₂ NRs at high temperature but also enhance its thermal stability and srOSC. Although shape-engineered nanocrystals (SENs) have the applications in a range of fields, including catalysis, photonics, optoelectronics, surface enhanced Raman scattering, and environmental issue, they often suffer from the poorer stability. Our method and the concept underlying this method could be adopted to improve thermal stability of other SENs while maintain or even enhance their unique functionalities.

METHODS

Preparation of CeO₂ nanorods.

The CeO₂ nanorods were synthesized through a hydrothermal method. Briefly, 8 mL of 6 M NaOH aqueous solution were added into 0.1 M Ce(NO₃)₃·6H₂O (Acros Organics 99.5%). This mixture was stirred for about 15 s in a Teflon bottle (200 mL). The Teflon-lined autoclave was then tightly sealed and transferred into a programmable box furnace. The hydrothermal reaction procedure was carried out at 90 °C (CeO₂-NR) for 48 hrs. After the autoclave was cooled down to room temperature, the precipitates were collected, and then washed with deionized water and ethanol. The as-prepared samples were obtained by drying in air at 60 °C overnight.

ALD Chemical and materials

ALD precursors are trimethyl aluminum (TMA) (98%, Strem Chemicals) and deionized water (DI H₂O) (18 MΩ, water filtration system from Thermo Fisher Scientific LLC). The carrier and purging gas for the ALD process is ultrahigh purity N₂ (99.999%, Airgas). Isopropyl alcohol (IPA) (99.5% BDH) was used to clean the sample holder. HNO₃ (68-70%, BDH) and H₂O₂ (30%, BDH) were used for the ICP measurement.

ALD sample holder cleaning

Sample holders used in the ALD process include ceramic boat and quartz tube are cleaned by 30 min sonication (Branson 5510) in DI water and IPA, respectively, and dried on the hotplate at 400 °C for 1 hour. The metal wire cloth (Gerard Daniel Worldwide) covered on the ceramic boat is cleaned by the same procedure.

ALD processes

Tubing method

A quartz tube with diameter of 10 mm was used as the ALD sample holder for CeO₂ nanorods. CeO₂ nanorods are loaded into the quartz tube with one side blocked by the quartz wool, another

side of the tube is also blocked by the quartz after the sample loading. The average CeO_2 nanorod bed thickness in the quartz tube is 3 mm. The precursors for the Al_2O_3 ALD are TMA and DI H_2O . Due to the difficulty of the gas diffusion into the closed packed nanorod sample bed, long exposure time was used for the precursors. The temperature of the ALD chamber is 200 °C. The ALD sequence is: pre-purge the sample for 20 mins; pumping down the system to 10^{-2} torr; shut down the pump; TMA pulsing for 8 s (~ 2 torr); TMA exposure for 5 min; pump out TMA until system is 10^{-2} torr; N_2 purging for 120 s; H_2O dose for 20 s with carrier gas flow; N_2 purging for 120 s. Repeat the sequence for another layer of coating. The chamber is continuously vibrating by a homemade vibrator during the ALD process.

Flat-boat method

A ceramic boat with flat bottom was used as the ALD sample holder for CeO_2 nanorods. Nanorods are loaded into the boat and shook into a thin film which uniformly cover the bottom of the boat. The film thickness is ~ 0.3 mm. The precursors for the Al_2O_3 ALD are TMA and DI H_2O .

1. Normal flat-boat ALD coating

The temperature of the ALD chamber is 200 °C. The ALD sequence is: pre-purge the sample for 20 mins; pumping down the system to 10^{-2} torr; shut down the pump; TMA pulsing for 8 s (~ 2 torr); TMA exposure for 5 min; pump out TMA until system is 10^{-2} torr; N_2 purging for 120 s; H_2O dose for 20 s with carrier gas flow; N_2 purging for 120 s. Repeat the sequence for another layer of coating.

2. Low temperature flat-boat ALD coating

To verify if the rate limiting step in this ALD coating process is the reaction speed, the ALD chamber temperature was set to 136 °C. Based on the Arrhenius Equation, the reaction speed at 136 °C should be around 1/10 of the reaction speed at 200 °C. Other ALD sequences are kept the same as the normal flat-boat ALD coating method.

3. 1/10 exposure time flat-boat ALD coating

To verify if the rate limiting step in this ALD coating process is the diffusion speed, the exposure time of the precursors are decreased into 1/10 of the normal exposure time. Therefore, the TMA exposure time is 30 s and the H₂O dose is 2 s. All the other experiment conditions and ALD sequences are kept the same as normal flat-boat ALD coating method.

Heat treatment

Samples were loaded into a quartz boat and annealed inside the heat furnace (Lindberg/Blue M, ThermoFisher) at 700 °C for 5 hours in air. The ramping rate of the temperature is 10 °C/min.

Characterizations

TEM

TEM (FEI Tecnai F-20) was used to verify the morphology change of the CeO₂ nanorods before and after the heat treatment. The nanorod powder sample was dispersed into the methanol by sonication and the solution was drop casted onto the copper TEM grid (Supported carbon film, 200 mesh, TED PELLA).

STEM

Electron microscopy was carried out using Hitachi HF3300 high-resolution TEM-STEM at 300 kV and Nion UltraSTEM 200 at 200 kV. EDX mapping was carried out using FEI Talos microscope at 200 kV.

TPR

Hydrogen temperature programmed reduction (H₂-TPR) was performed using a Micrometrics AutoChem™ II 2920 with the temperature rising from ambient temperature to 700 °C at a rate of 10 °C/min. The gas mixture of 5% H₂ and 95% Ar passed through the different samples (~100 mg or normalized after ALD) loaded in a quartz U-type reactor with flowing rate of 50 mL/min.

H₂-TPR cycling experiment were performed 10 times in the same experimental apparatus with temperature also rising from ambient temperature to 700 °C. Between each H₂-TPR cycle, the quartz U-type reactor was taken down from the instrument and exposed in air for 24 hrs.

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Figures

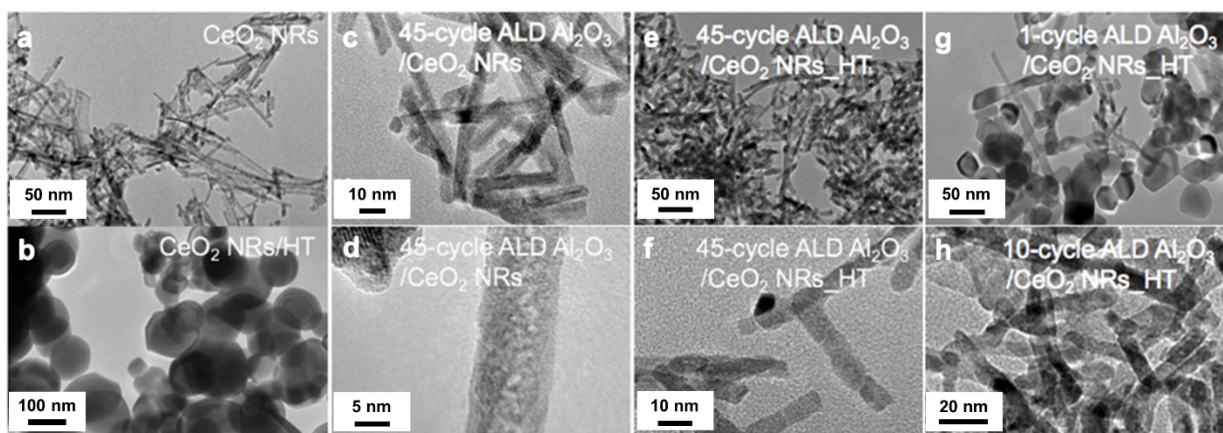


Figure 1. TEM images of (a) CeO₂ NRs; (b) CeO₂NRs_HT (CeO₂ NRs after HT); (c, d) CeO₂ NRs/45Al₂O₃; (e, f) CeO₂ NRs/45Al₂O₃_HT; (g) CeO₂ NRs/1Al₂O₃_HT; (h) CeO₂ NRs/45Al₂O₃. CeO₂ NRs/nAl₂O₃_HT: CeO₂ NRs with n cycles of Al₂O₃ ALD coating followed by HT. HT: heat treatment at 700 °C in N₂ for 5 h. ALD Al₂O₃ is carried at 200 °C with trimethyl aluminum [Al(CH₃)₃] & H₂O as the reactants.

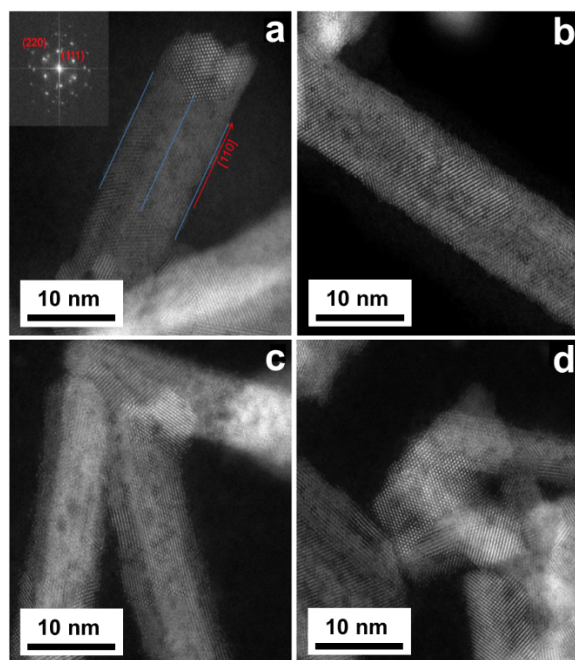


Figure 2. HRTEM of fresh CeO_2 NRs (**a** and **b**) and $\text{CeO}_2\text{NRs}/45\text{Al}_2\text{O}_3$ (**c** and **d**) before the thermal treatment. The inset figure in (**a**) shows the corresponding Fourier transform image of the CeO_2 NR. The arrow in (**a**) illustrates the $[110]$ direction of CeO_2 NRs.

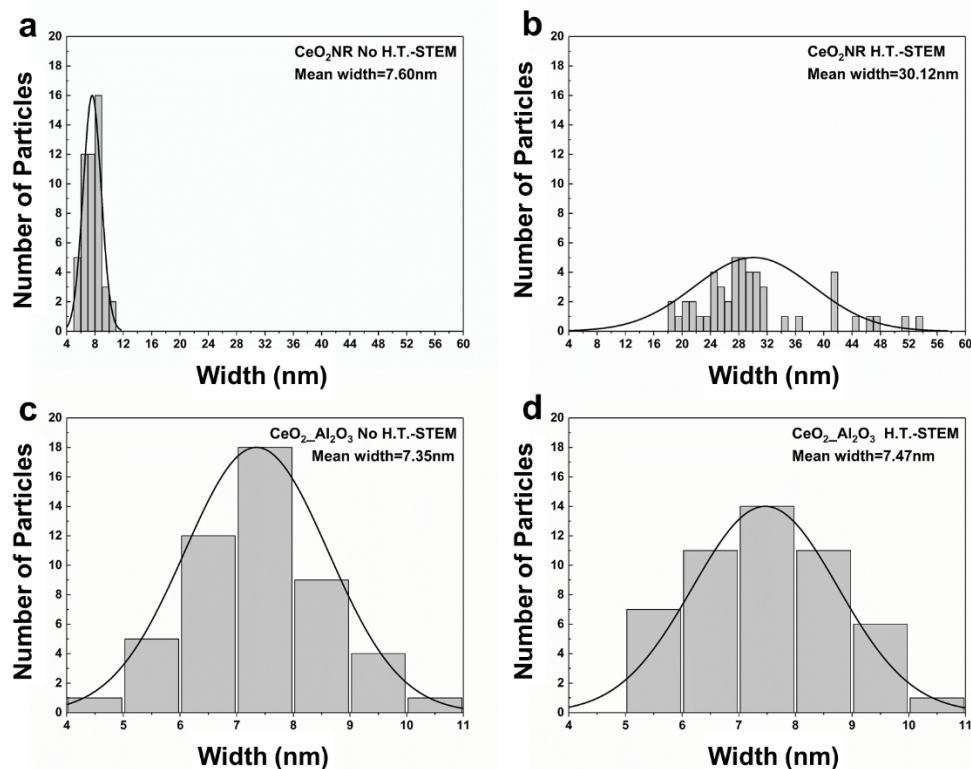


Figure 3. CeO₂ nanoparticle size distribution of (a) Non-treated CeO₂ NRs; (b) Non-treated CeO₂ NRs after HT; (c) 45-c ALD treated CeO₂ NRs; (d) 45-c ALD treated CeO₂ NRs after HT. Average size of the non-treated CeO₂ nanoparticles increased significantly after HT but remain the same after ALD treatment and HT after ALD treatment. Morphology of the CeO₂ NRs stabilized at least at 700°C.

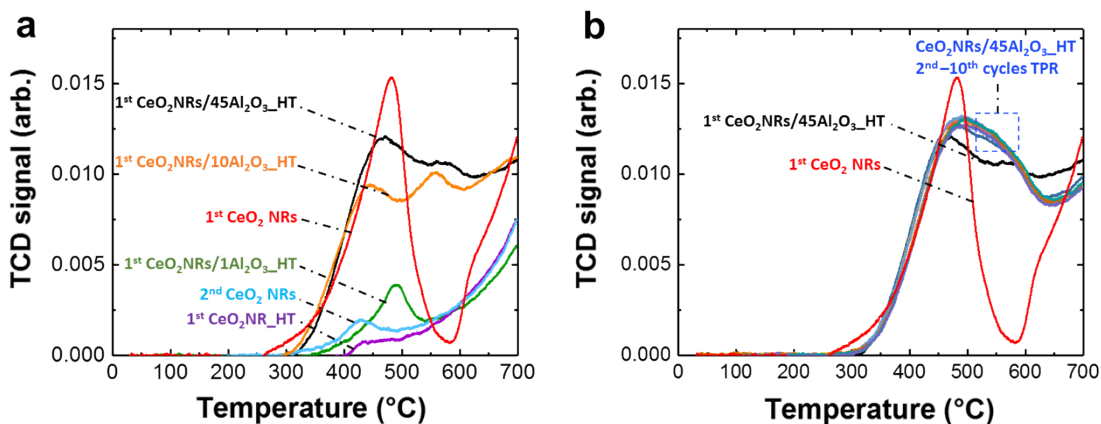


Figure 4. H₂ TPR profile of **(a)** Non-treated CeO₂ NRs in 1st – 2nd cycles of TPR; non-treated CeO₂ NRs after HT; 1, 10, 45 cycles ALD treated CeO₂ NRs after HT for comparison; **(b)** Non-treated CeO₂ NRs 1st cycle TPR; 45Al₂O₃/CeO₂NR_HT in the 1st – 10th cycles of TPR for recyclable high temperature reaction. The amount of H₂ uptake is normalized to the weight of the sample. The area underneath a curve is a measure of OSC of samples. The ALD Al₂O₃ treated samples should have larger peaks than that in the figure if we use the CeO₂ as the mass base. The low temperature peak at ~ 480 °C is from surface oxygen. The reduction of bulk oxygen from CeO₂ NRs has a peak located at > 700 °C. The temperature ramping rate in TPR is 10 °C/min.

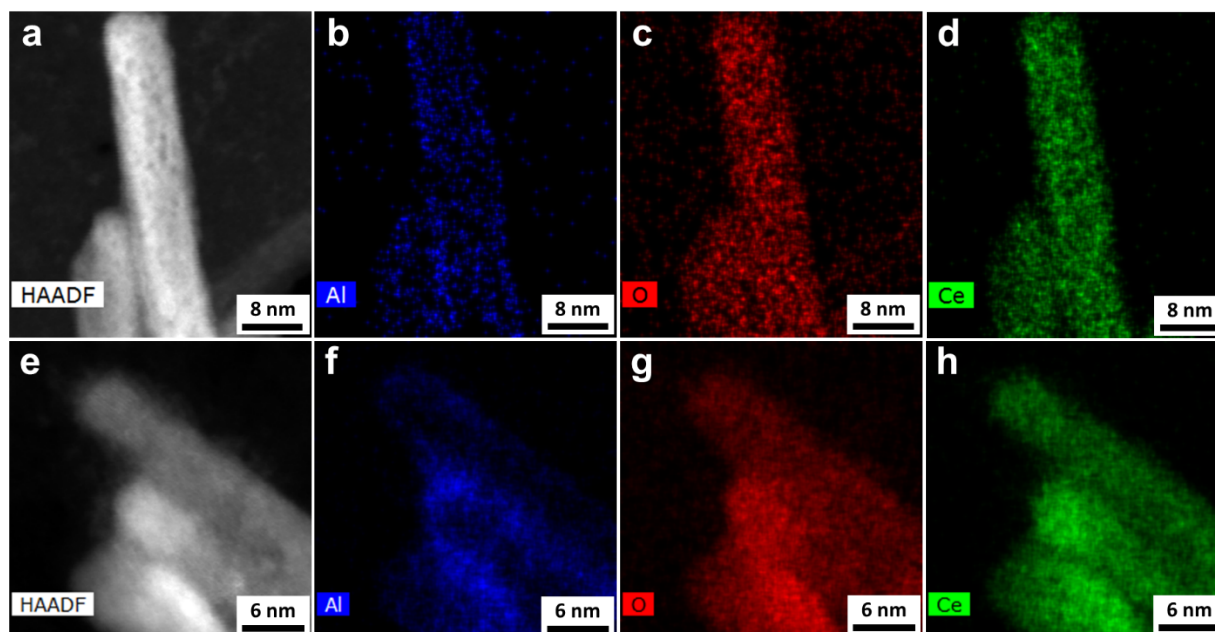


Figure 5. HAADF-STEM EDAX mapping of two selected $\text{CeO}_2\text{NRs}/45\text{Al}_2\text{O}_3$ samples, (a-b) sample 1 and (e-h) sample 2. Morphology is shown in (a and e). Ce (d and h) and O (c and g) are everywhere inside the nanorods. Al (b-f) is only on the surface of the nanorods.

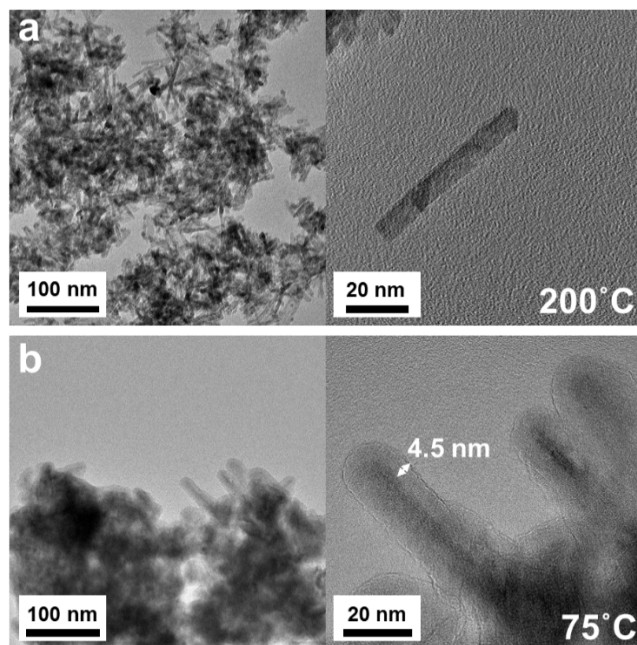


Figure 6. TEM morphology images of $\text{CeO}_2\text{NR}/45\text{Al}_2\text{O}_3$ generated at (a) 200 °C and (b) at 75 °C via the same ALD Al_2O_3 sequence. No shell can be seen on the sample generated at 200 °C. An Al_2O_3 shell with thickness ~ 4.5 nm can be clearly seen on the sample generated at 75 °C.

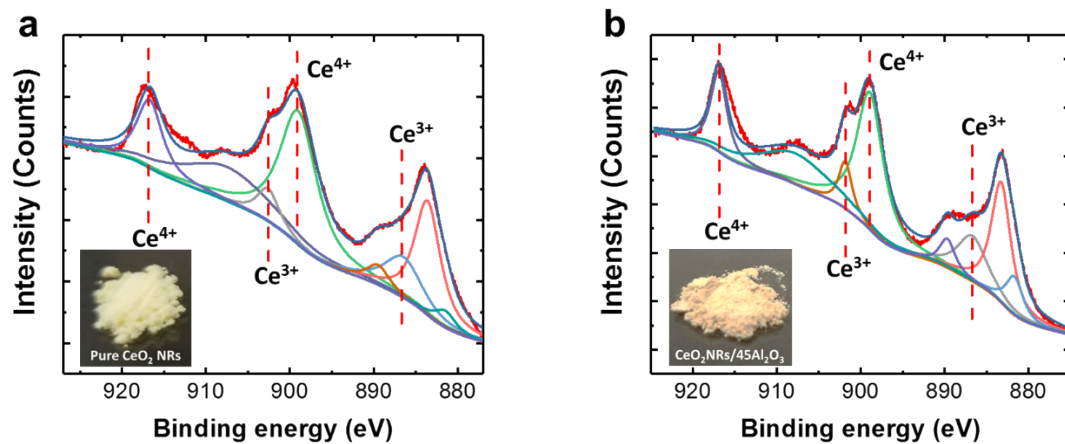


Figure 7. XPS spectra of (a) CeO_2 NRs and (b) CeO_2 NRs/45 Al_2O_3 . The concentration of Ce^{3+} increased after 45 Al_2O_3 ALD cycles at 200 °C. CeO_2 has been reduced, more O_2 vacancies created. The inset images show the color of the corresponding samples.

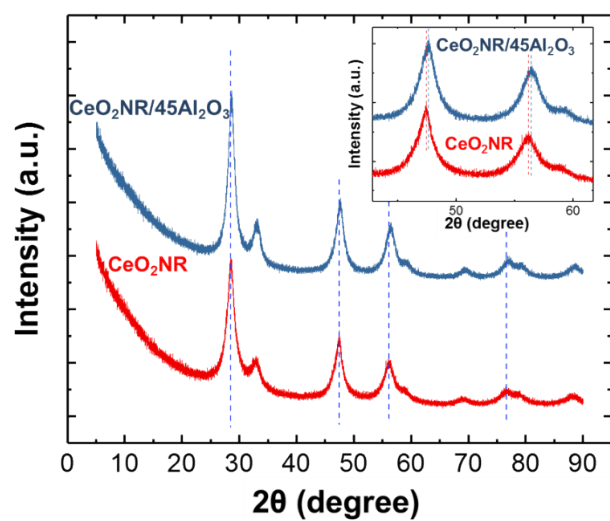


Figure 8. XRD spectra of CeO_2 NRs (bottom) and $\text{CeO}_2\text{NRs}/45\text{Al}_2\text{O}_3$ (top). XRD peaks shifted to higher 2θ after 45 cycles Al_2O_3 ALD at 200 °C, suggesting that the lattice constant of $\text{CeO}_2\text{NRs}/45\text{Al}_2\text{O}_3$ is smaller than that of CeO_2 NRs.

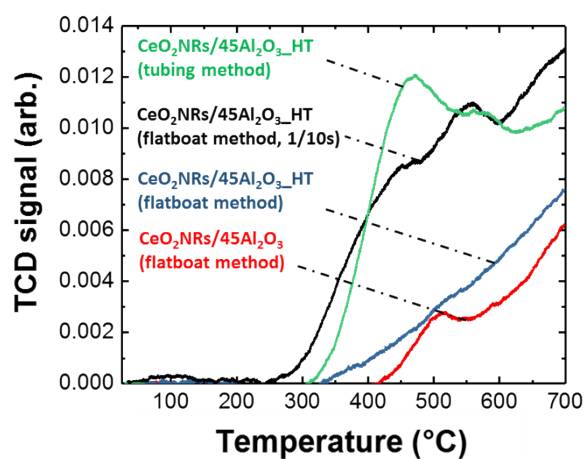


Figure 9. H₂ TPR of CeO₂NR/45Al₂O₃ by tubing method (300 s TMA exposure and 20 s water dose) after HT, CeO₂NR/45Al₂O₃ by flatboat method before and after HT, CeO₂NR/45Al₂O₃ by flatboat method with 1/10 TMA and water exposure time (30s TMA exposure and 2s water dose) after HT. The temperature ramping rate in TPR is 10 °C/min.

Supplemental Information

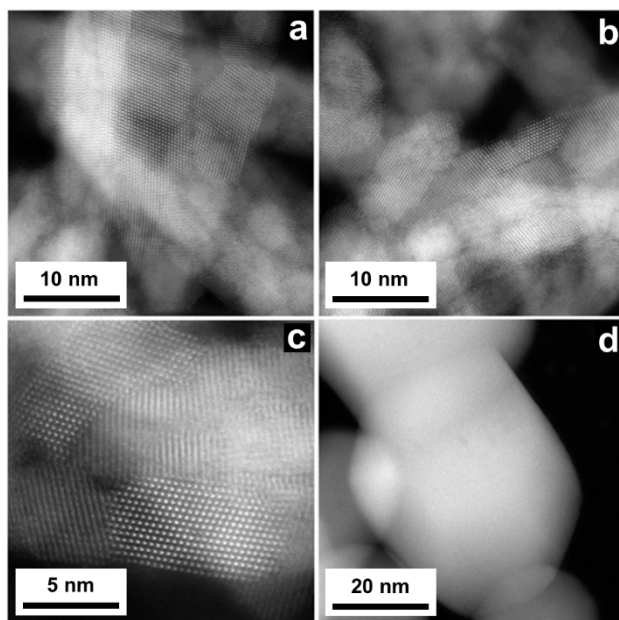


Figure S1. STEM images of (a-c) $\text{CeO}_2\text{NRs}/45\text{Al}_2\text{O}_3\text{_{HT}}$ and (d) $\text{CeO}_2\text{NRs}_{\text{HT}}$.

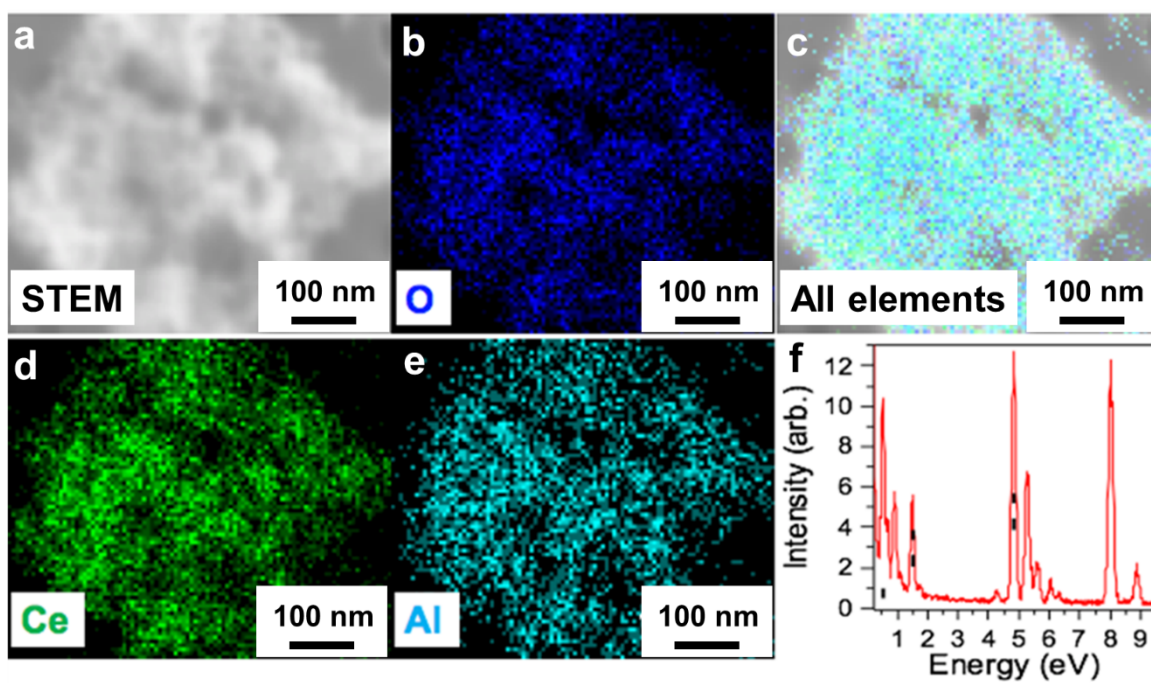


Figure S2. STEM EDAX mapping of overall $\text{CeO}_2\text{NRs}/45\text{Al}_2\text{O}_3$ sample. Both the imaging data and the spectrum shows the Al is evenly distributed on the nanorods.